



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Byung-Chul AHN et al.

Serial No.

08/918,119

Filed:

August 27, 1997

For:

THIN FILM TRANSISTOR AND METHOD OF MAKING SAME

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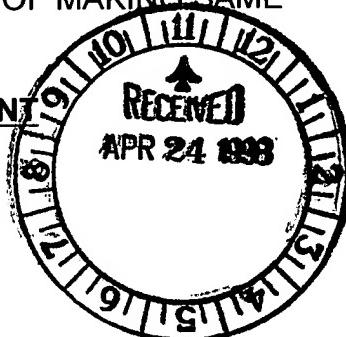
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Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:



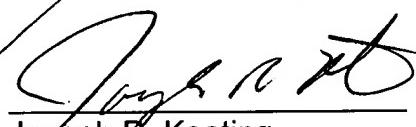
Submitted herewith is a certified copy of Korean Priority Application No. 97-7010 filed March 4, 1997, to perfect the claim to priority, under the provision of 35 U.S.C. §119, in the above-identified application. It is respectfully requested that this application be accorded the benefit of the filing date of said earlier application and that the attached certified copy be entered into and made a part of the record herein.

Respectfully submitted,

Byung-Chul AHN et al.

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Per:


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April 16, 1998